

Matrix Reactions of Methylsilanes and Oxygen Atoms

Robert Withnall and Lester Andrews*

Department of Chemistry, University of Virginia, Charlottesville, Virginia 22901 (Received: May 26, 1987)

The reactions of oxygen atoms and substituted methylsilanes have been investigated in argon matrices at 14–17 K. Products were identified by using isotopic $^{18}\text{O}_3$ precursor and deuterium substitution in the Si–H bonds. With MeSiH_3 , Me_2SiH_2 , and Si_2H_6 , the silanols MeSiH_2OH , Me_2SiHOH , and $\text{SiH}_3\text{SiH}_2\text{OH}$ were formed, respectively. These molecules contain the Si–O–H functional group with 3708–3711- cm^{-1} O–H stretching frequencies. For Me_4Si , the carbinol $\text{Me}_3\text{SiCH}_2\text{OH}$ was produced with a lower 3637- cm^{-1} O–H stretching frequency. Me_3SiH was different: the silanol was not observed, but instead a product tentatively identified as $\text{CH}_2=\text{Si}(\text{OH})\text{Me}$ was formed. Also, the silanones H_2SiO and $\text{Me}(\text{H})\text{SiO}$ were produced from MeSiH_3 , $\text{Me}(\text{H})\text{SiO}$ and Me_2SiO were formed with Me_2SiH_2 , and Me_2SiO was again observed with Me_3SiH . These silanones contain the Si=O functional group with stretching frequencies of 1201–1209 cm^{-1} .

Introduction

A previous study of matrix reactions of SiH_4 and oxygen atoms provided a unique method of synthesis for molecules containing SiOH and Si=O functional groups.¹ The limited vibrational data on these species, which include Cl_3SiOH^2 and $\text{Me}_2\text{Si}(\text{OH})_2^3$ and a detection of $\text{Me}_2\text{Si}=\text{O}$,⁴ justify a thorough parallel study of the reactions of methyl-substituted silanes and oxygen atoms. Infrared spectroscopic evidence for methyl- and dimethylsilanones, formed in the reactions of methyl-substituted silanes and oxygen atoms, was reported briefly in a recent communication.⁵

Experimental Section

Apparatus. The cryogenic refrigeration system and vacuum vessel have been described previously.⁶ All spectra were recorded on a Perkin-Elmer 983 spectrophotometer over the range 180–4000 cm^{-1} ; the frequency accuracy of band locations is $\pm 0.2 \text{ cm}^{-1}$. Samples were irradiated for periods up to 1.0 h by using a BH-6 high-pressure mercury arc lamp (1000 W; Illumination Industries Inc.) in combination with Corning glass and a 10-cm water filter, which exposed the samples to the following wavelength ranges: A, 420–1000 nm; B, 290–1000 nm; C, full arc 220–1000 nm.

Chemicals. Ozone was generated by Tesla coil discharge of oxygen (normal isotopic, Burdett, USP grade; 55% and 95% ^{18}O enriched, Yeda) in a Pyrex tube immersed in liquid N_2 ; residual O_2 was removed by pumping by 77 K.⁷ MeSiH_3 , Me_2SiH_2 , Me_3SiH , and Me_4Si were obtained from Petrarch Systems. Si_2H_6 was prepared by reduction of Si_2Cl_6 (Pfaltz and Bauer) with LiAlH_4 (Aldrich) in ether solution.⁸ Deuterated silanes were prepared by reduction of the chlorides (Aldrich) with LiAlD_4 (Aldrich) in ether solution.⁸

Procedure. (i) Samples of methyl-substituted silane ($\text{Ar}/\text{Me}_n\text{SiH}_{4-n} = 200/1$, $n = 1, 2, 3, 4$) or disilane and ozone ($\text{Ar}/\text{O}_3 = 150/1$) were codeposited at 14–17 K through two separate spray-on lines at equal rates of 1–2 mmol/h for 10 h. Samples were irradiated after deposition, and more spectra were recorded.

(ii) O atoms were generated by the microwave discharge (Burdick; 2450 MHz) of an Ar/O_2 stream in a 6-mm-o.d. quartz tube directed at the cold window using Ar/O_2 gas mixtures of 100/1. The argon/ O_2 /O atom stream was codeposited with $\text{Ar}/\text{methylsilane}$ samples of approximately 10 h.

Results

$\text{MeSiH}_3 + ^{16}\text{O}_3$. An infrared spectrum recorded immediately after reagent codeposition is shown in Figure 1a. The infrared

TABLE I: Absorbances of Product Bands after Irradiations A, B, and C of Argon Matrix Containing MeSiH_3 and $^{16}\text{O}_3$

ν/cm^{-1}	A	B	C	ident ^a
509.7	0.01	0.02	0.04	MS
593.0			0.03	
718.5	0.11	0.24	0.58	MS
734.4	0.03	0.06	0.19	
752.4	0.025	0.05	0.15	
797.4	0.04	0.075	0.20	MS
835.3	0.02	0.05	0.18	
877.1	b	b	b	
922.4	b	b	b	
962	b	b	b	
976.7	0.05	0.13	0.45	MS
1017.4		0.03	0.11	
1201.7		0.01	0.04	B
1207.6		0.03	0.11	M
1303.3			0.03	CH_4
2127.4	0.12	0.24	0.62	MS
2138.0	0.12	0.26	0.64	MS
3716.0	0.045	0.105	0.30	MS

^a MS denotes methylsilanol, M identifies methylsilanone, and B denotes silanone. ^b Unresolved in survey scan from MeSiH_3 precursor.

spectrum of MeSiH_3 isolated in an argon matrix is in agreement with a previous study⁹ except for the 1400- cm^{-1} region. The MeSiH_3 molecule almost certainly assumes a C_{3v} conformation as in the gas phase.¹⁰ In the 1350–1459- cm^{-1} region, where the $\nu_9(\text{e})$ CH_3 deformation is expected by comparison with gas-phase studies,^{10–12} a strong band was observed at 1440.5 cm^{-1} and a doublet of medium intensity at 1376.5 and 1381.2 cm^{-1} with weaker site splittings at 1389.5 and 1395.7 cm^{-1} . The split bands are most likely due to Fermi resonance between ν_9 and the $\nu_{11} + \nu_{12}$ mode as has been noted before⁹ with the band at 1440.5 cm^{-1} belonging to ν_9 and the doublet at 1376.5 and 1381.2 cm^{-1} belonging to $\nu_{11} + \nu_{12}$. For MeSiD_3 , $\nu_{11} + \nu_{12}$ was red-shifted to the 1200–1300- cm^{-1} region and a single, strong band was observed at 1421.8 cm^{-1} . In gas-phase studies of MeSiH_3 , ν_9 has been assigned the frequencies 1403 cm^{-1} ^{10,11} and 1430 cm^{-1} ,¹² and this discrepancy is almost certainly due to complications in the spectrum arising from the Fermi resonance interaction.

Irradiation A produced new bands which are listed in Table I. These bands increased with irradiations B and C (Table I). Figure 1b shows the 180–4000- cm^{-1} region of the survey infrared spectrum which was recorded following irradiation C. Particularly diagnostic absorptions include a band in the O–H stretching region at 3716.0 cm^{-1} (Figure 2a), two strong bands in the Si–H stretching region at 2127.4 and 2138.0 cm^{-1} (Figure 2b), and a

(1) Withnall, R.; Andrews, L. *J. Phys. Chem.* **1985**, *89*, 3261.
 (2) Shirk, A. E.; Shirk, J. S. *J. Mol. Spectrosc.* **1982**, *92*, 218.
 (3) Ho, T. D. *Appl. Spectrosc.* **1986**, *40*, 29.
 (4) Arrington, C. A.; West, R.; Michl, J. *J. Am. Chem. Soc.* **1983**, *105*, 6176.
 (5) Withnall, R.; Andrews, L. *J. Am. Chem. Soc.* **1986**, *108*, 8118.
 (6) Andrews, L. *J. Chem. Phys.* **1968**, *48*, 972.
 (7) Andrews, L.; Spiker, R. C., Jr. *J. Phys. Chem.* **1972**, *76*, 3208.
 (8) Finholt, A. E.; Bond, A. C., Jr.; Wilzbach, K. E.; Schlesinger, H. I. *J. Am. Chem. Soc.* **1947**, *69*, 2692.

(9) Oxtan, T. A. *J. Mol. Struct.* **1979**, *56*, 57.
 (10) Wilde, R. E. *J. Mol. Spectrosc.* **1962**, *8*, 427.
 (11) Sin'ko, S. V.; Pertin, Y. A.; Gol'din, G. S.; Kuramshira, G. M. *Russ. J. Phys. Chem. (Engl. Transl.)* **1985**, *59*, 1604.
 (12) Randic, M. *Spectrochim. Acta* **1962**, *18*, 115.

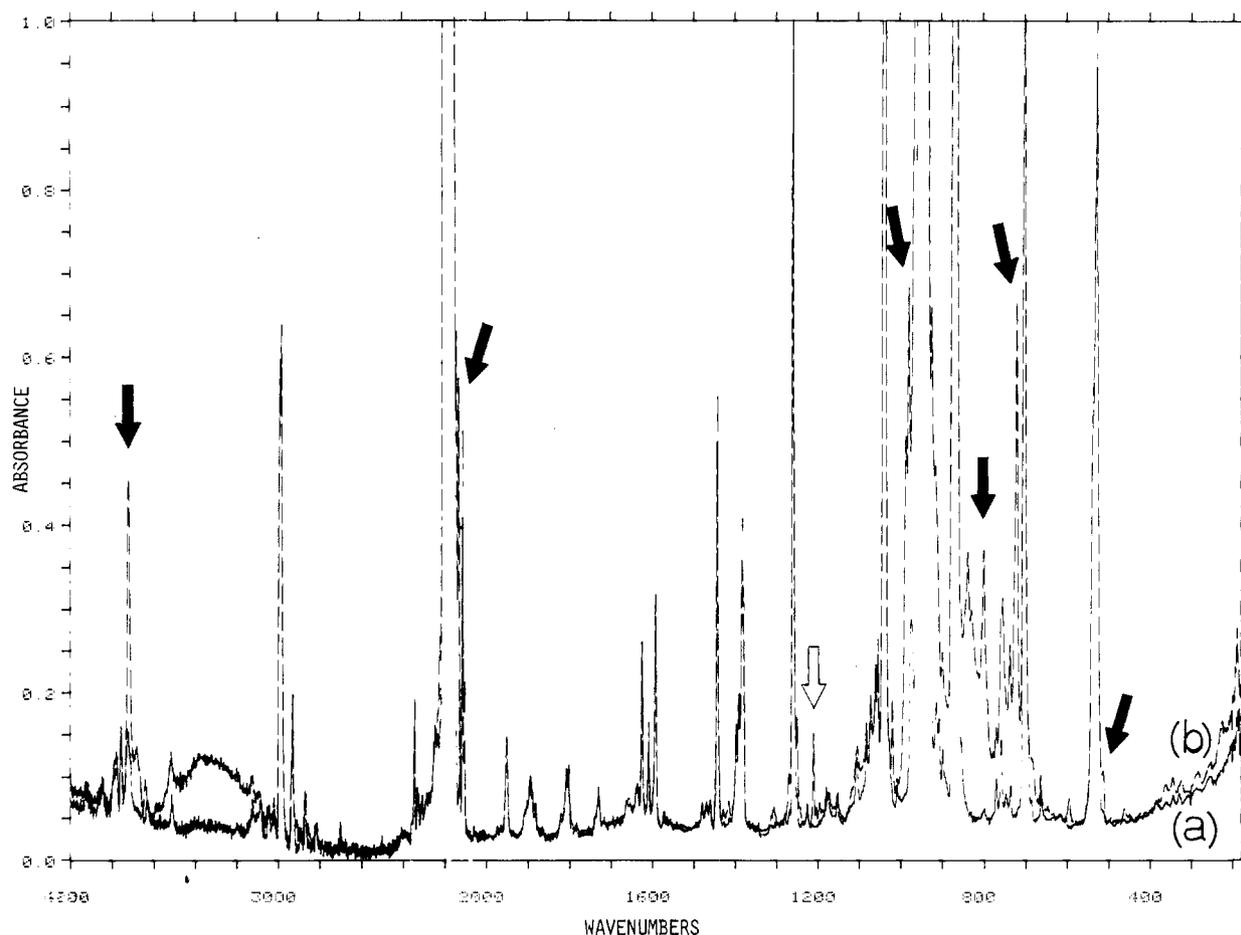


Figure 1. Infrared spectra of a sample of Ar/MeSiH₃/¹⁶O₃ = 1200/3/4 in the 180–4000-cm⁻¹ region (a) immediately after deposition at 14–17 K; (b) after irradiation C. Bold arrows indicate methylsilanol (MS) absorptions, and the light arrow shows a methylsilanone (M) band.

TABLE II: Isotopic Absorptions (cm⁻¹) Appearing on Irradiation of Argon Matrix Containing Methylsilane and Ozone

CH ₃ SiH ₃		CH ₃ SiD ₃		ident
¹⁶ O ₃	¹⁸ O ₃	¹⁶ O ₃	¹⁸ O ₃	
509.7	509.8			MS
593.0	590.1			
718.5	717.8	548 br	547 br	MS
734.4	732.8			
752.4	751.4			
797.4	793.5	786.0	783.4	MS
877.1	877.1			
		876.4 vs	859.4	MS
910	913.0			
922.4	922.2			
962	962.6			
976.7	<i>a</i>	753.7	745.4	MS
1017.4	<i>a</i>			
1201.7	1162.7			B
1207.6	1170.6	1202.3	1165.4	M
1303.3	1303.3	1303.3	1303.3	CH ₄
2127.4	2127.4	<i>b</i>	<i>b</i>	MS
2138.0	2138.0	<i>b</i>	<i>b</i>	MS
3716.0	3704.2	2739.9	2720.9	MS

^a Masked by ν₃ of ¹⁸O₃. ^b Unresolved from MeSiD₃ precursor.

strong band at 718.5 cm⁻¹ (Figure 2c). Bands in the Si=O stretching region at 1207.6 cm⁻¹ and 1201.7 cm⁻¹ (labeled M and B, respectively, in Figure 2d) were not present following irradiation A but appeared on irradiation B and increased markedly on irradiation C.

MeSiH₃ + ¹⁸O₃. Similar experiments were performed with MeSiH₃ and ¹⁸O₃ (95% ¹⁸O). In the O–H stretching region, the MS band at 3716.0 cm⁻¹ was red-shifted to 3704.2 cm⁻¹ and the M band at 1207.6 cm⁻¹ was red-shifted to 1170.6 cm⁻¹. The other bands showed little or no ¹⁸O shift as can be seen from Table II.

TABLE III: Isotopic Absorptions (cm⁻¹) Appearing on Full-Arc Irradiation of Argon Matrix Containing Disilane and Ozone

Si ₂ H ₆		Si ₂ D ₆	
¹⁶ O ₃	¹⁸ O ₃	¹⁶ O ₃	¹⁸ O ₃
521.7	521.0		
748 br	746 br	556.9	555.4
855.0	852.1	637.4	635.9
		862.0	836.0
950.6	948.4		
961.6	961.6	704.4	704.4
3708.5	3697.0	2733.5	2716.8

An experiment with ^{16,18}O₃ (55% ¹⁸O) gave only the photoproducts from the pure ¹⁶O₃ and ¹⁸O₃ isotopic experiments.

MeSiD₃ + O₃. Samples of MeSiD₃ and ozone were codeposited and photolyzed; new bands are listed in Table II. A very intense MS absorption at 876.4 cm⁻¹ was red-shifted to 859.4 cm⁻¹ with ¹⁸O. This ¹⁸O shift of 17.0 cm⁻¹ is considerably higher than the ¹⁸O shift of any of the MS bands in this spectral region in CH₃SiH₃ experiments. Another noteworthy MS band appeared at 2739.9 cm⁻¹, in the O–D stretching region, and showed a red shift of 19.0 cm⁻¹ with ¹⁸O. The M band at 1207.6 cm⁻¹ shifted to 1202.3 cm⁻¹ with MeSiD₃.

MeSiH₃ + O. Samples of methylsilane (Ar/MeSiH₃ = 100/1) were codeposited with oxygen (Ar/O₂ = 100/1) passed through a microwave discharge tube for 8 h. Absorptions observed in MeSiH₃/O₃ experiments that belong to species MS (Table I) also appeared here. Other bands not present in MeSiH₃/O₃ experiments were produced here and with vacuum-ultraviolet photolysis of Ar/MeSiH₃ matrices alone.¹³ With ¹⁸O, isotopic MS bands were also observed.

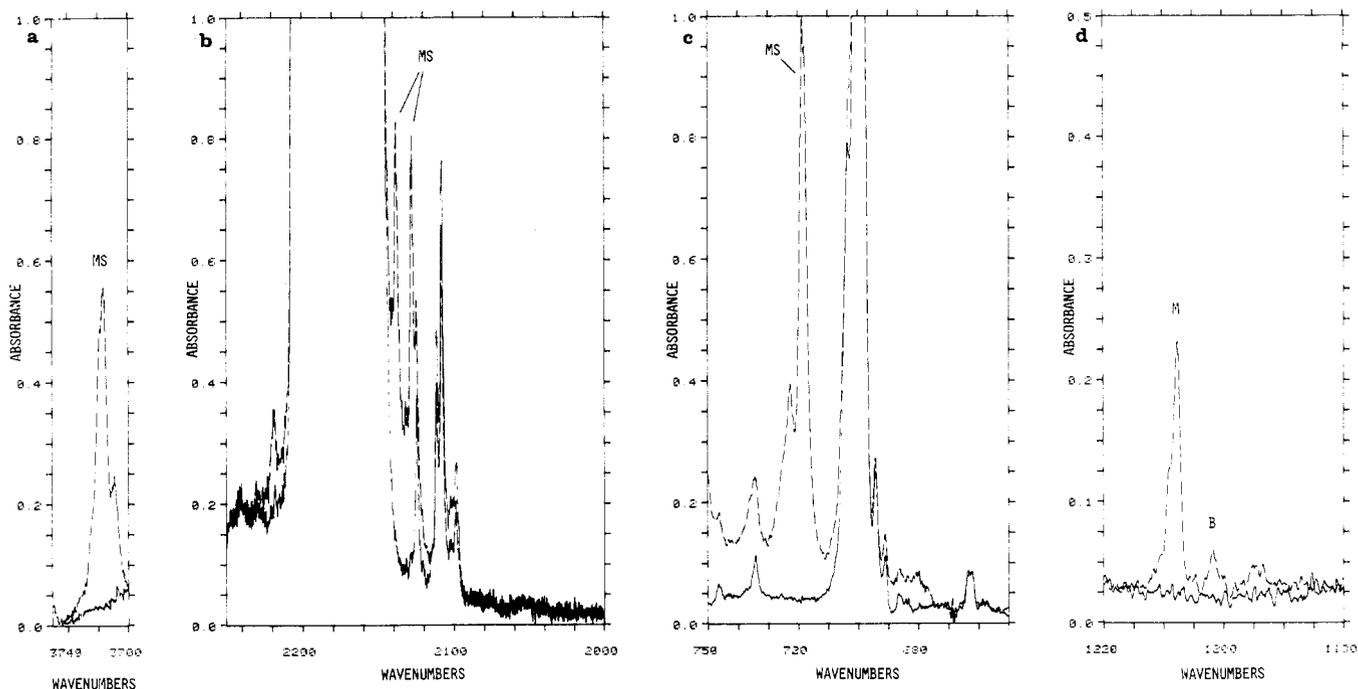


Figure 2. (a) Infrared spectrum of a sample of Ar/MeSiH₃/¹⁶O₃ = 1200/3/4 before (solid trace) and after (dashed trace) irradiation C at 14–17 K in the 2000–2250-cm⁻¹ region. (b) Infrared spectrum of a sample of Ar/MeSiH₃/¹⁶O₃ = 1200/3/4 before (solid trace) and after (dashed trace) irradiation C at 14–17 K in the 2000–2250-cm⁻¹ region. (c) Infrared spectra of a sample of Ar/MeSiH₃/¹⁶O₃ = 1200/3/4 before (solid trace) and after (dashed trace) irradiation C at 14–17 K in the 650–750-cm⁻¹ region. (d) Infrared spectra of a sample of Ar/MeSiH₃/¹⁶O₃ = 400/1/1 before (solid trace) and after (dashed trace) irradiation C at 12 K in the 1160–1220-cm⁻¹ region.

TABLE IV: Absorptions of Product Bands after Irradiations A, B, and C of Argon Matrix Containing Me₂SiH₂ and ¹⁶O₃

ν/cm^{-1}	A	B	C	ident ^a
283	0.01	0.03	0.05	DS
616.2	0.02	0.05	0.09	DS
707.3	<i>b</i>	<i>b</i>	<i>b</i>	DS
711.0	<i>b</i>	<i>b</i>	<i>b</i>	DS
738.5	0.01	0.05	0.08	
757.2	0.05	0.24	0.38	DS
764.5	0.04	0.20	0.28	DS
808.8	0.13	0.16	0.31	
819.4	0.27	0.50	1.25	DS
925	<i>b</i>	<i>b</i>	<i>b</i>	DS
1207.4		0.01	0.04	M
1209.6	0.015	0.035	0.095	D
1303.3			0.04	CH ₄
2111.0	0.25	0.55	1.25	DS
3717.1	0.05	0.20	0.29	DS

^aDS denotes dimethylsilanol, M identifies methylsilanone, and D denotes dimethylsilanone. ^bUnresolved in survey scan from Me₂SiH₂ precursor.

Si₂H₆ + O₃. The infrared spectrum of Si₂H₆ in solid argon was in good agreement with the previously reported spectrum.¹⁴ Exposure of Ar/Si₂H₆/O₃ matrices to full-arc radiation produced new bands which are listed in Table III. Particularly diagnostic absorptions appeared at 3708.5 and 748 cm⁻¹. No product bands were observed in the Si—O and Si=O stretching regions. A similar experiment with Si₂H₆ and ¹⁸O₃ shifted the O—H stretching band to 3697.0 cm⁻¹ as given in Table III. An experiment with Si₂H₆ and scrambled ^{16,18}O₃ (55% ¹⁸O) gave only bands which were produced in ¹⁶O₃ and ¹⁸O₃ experiments.

Si₂D₆ + O₃. The diagnostic absorption appeared in the O—D stretching region at 2733.5 cm⁻¹ following photolysis of Si₂D₆ and ozone and was red-shifted to 2716.8 cm⁻¹ with ¹⁸O₃. A strong product band at 862.0 cm⁻¹ was shifted to 836.0 cm⁻¹ with ¹⁸O substitution.

Me₂SiH₂ + ¹⁶O₃. An infrared spectrum recorded immediately after reagent codeposition is shown in Figure 3a. The spectrum

TABLE V: Isotopic Absorptions (cm⁻¹) Appearing on Irradiation of Argon Matrix Containing Dimethylsilane and Ozone

(CH ₃) ₂ SiH ₂		(CH ₃) ₂ SiD ₂		ident
¹⁶ O ₃	¹⁸ O ₃	¹⁶ O ₃	¹⁸ O ₃	
283	283	281	279	DS
616.2	616.2	514.2	514.2	DS
		668.6	668	
707.3	705.6			DS
711.0	708.5			DS
738.5	733.4			
757.2, 764.5	755.5, 763.4	621.1	609.6	DS
		758.4	758.9	
		769.7	768.6	
808.8	798.7			DS
819.4	810.3			DS
925	925	811	811	DS
		886.2 vs	875.2	DS
	1025.0		1025.0	carbinol
1207.4	1170.4	1202.3	1165.4	M
1209.6	1174.4	1209.6	1174.4	D
1212.1	1176.5			
1303.3	1303.3			CH ₄
2111.0	2111.0	<i>a</i>	<i>a</i>	DS
3717.1	3705.2	2740.2	2723.5	DS

^aUnresolved from Me₂SiD₂ precursor.

of Me₂SiH₂ in solid argon is in good agreement with gas-phase data.¹⁵ Exposure of Ar/Me₂SiH₂/¹⁶O₃ matrices to irradiation with the 590-nm cutoff filter produced new DS bands which are listed in Table IV along with their intensities. These bands increased intensity with irradiations A–C (Table IV). Figure 3b shows the 180–4000-cm⁻¹ region of the survey infrared spectrum which was recorded following irradiation C. Particularly diagnostic DS bands come at 3717.1 cm⁻¹ in the O—H stretching region (Figure 4a), 2111.0 cm⁻¹ in the Si—H stretching region (Figure 4b), at 707.3 and 711.0 cm⁻¹ (Figure 4c), and at 283 cm⁻¹ in the C—Si—C bending region. In the Si=O stretching region a D band at 1209.6 cm⁻¹ and a M band at 1207.4 cm⁻¹ appeared with

(14) Milligan, D. E.; Jacox, M. E. *J. Chem. Phys.* **1970**, *52*, 2594.

(15) Ball, D. F.; Goggin, P. L.; McKean, D. C.; Woodward, L. A. *Spectrochim. Acta* **1960**, *16*, 1358.

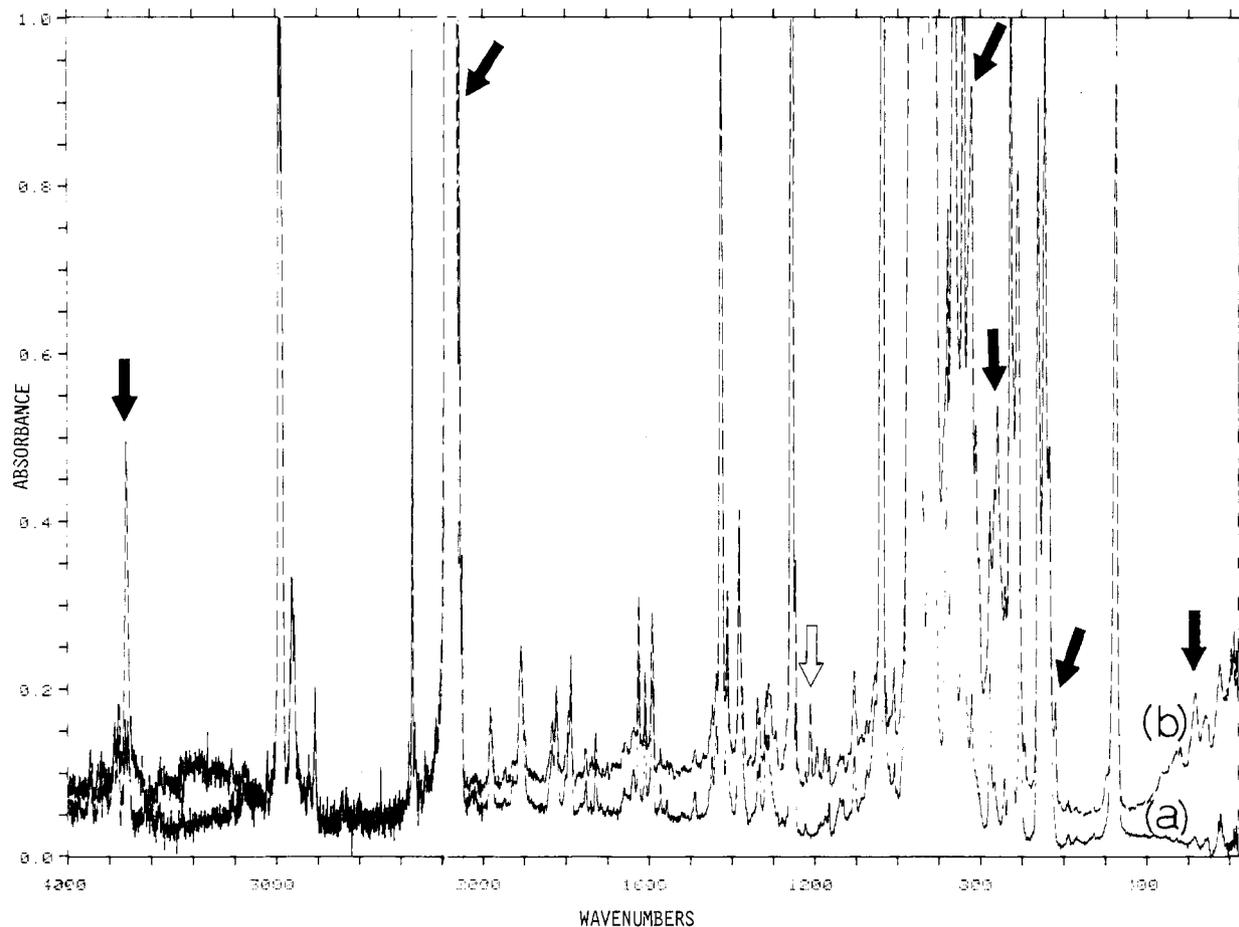


Figure 3. Infrared spectra of a sample of $\text{Ar}/\text{Me}_2\text{SiH}_2/^{16}\text{O}_3 = 1200/3/4$ in the $180\text{--}4000\text{-cm}^{-1}$ region (a) immediately after deposition at $14\text{--}17\text{ K}$; (b) after irradiation C. Bold arrows indicate dimethylsilanol (DS) absorptions, and the light arrow shows a dimethylsilanone (D) band.

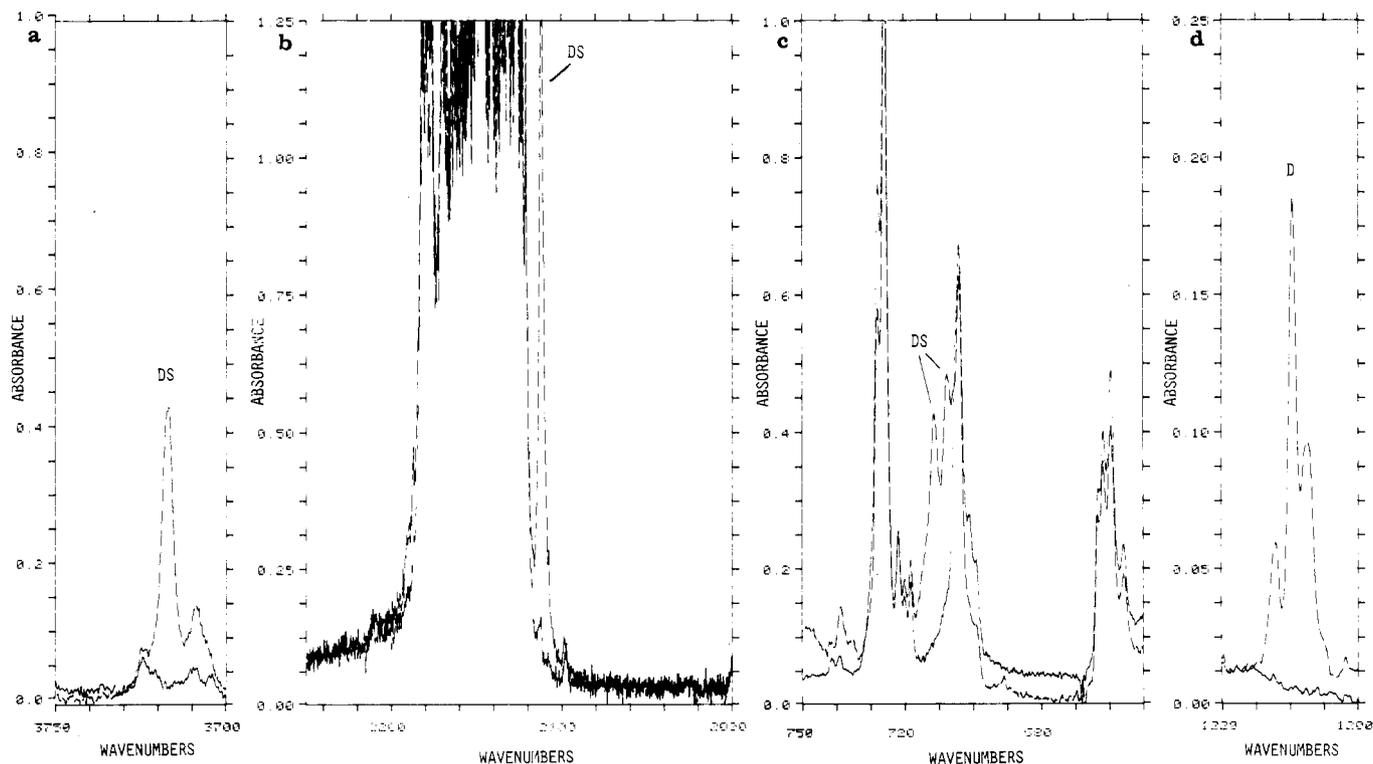


Figure 4. (a) Infrared spectra of a sample of $\text{Ar}/\text{Me}_2\text{SiH}_2/^{16}\text{O}_3 = 2400/3/8$ before (solid trace) and after (dashed trace) irradiation C at $14\text{--}17\text{ K}$ in the $3700\text{--}3750\text{-cm}^{-1}$ region. (b) Infrared spectra of a sample of $\text{Ar}/\text{Me}_2\text{SiH}_2/^{16}\text{O}_3 = 2400/3/8$ before (solid trace) and after (dashed trace) irradiation C at $14\text{--}17\text{ K}$ in the $2000\text{--}2250\text{-cm}^{-1}$ region. (c) Infrared spectra of a sample of $\text{Ar}/\text{Me}_2\text{SiH}_2/^{16}\text{O}_3 = 2400/3/8$ before (solid trace) and after (dashed trace) irradiation C at $14\text{--}17\text{ K}$ in the $650\text{--}750\text{-cm}^{-1}$ region. (d) Infrared spectra of a sample of $\text{Ar}/\text{Me}_2\text{SiH}_2/^{16}\text{O}_3 = 400/1/1$ before (solid trace) and after (dashed trace) irradiation C at 12 K in the $1160\text{--}1220\text{-cm}^{-1}$ region.

TABLE VI: Absorbances of Product Bands after Irradiations A, B, and C of Argon Matrix Containing Me₃SiH and ¹⁶O₃

ν/cm^{-1}	A	B	C	ident
285.4	0.035	0.07	0.08	X
303.7	0.02	0.04	0.04	
346.9			0.015	
360.2	0.01	0.03	0.03	X
685		0.025	0.025	
729.6	0.15	0.35	0.42	X
745	0.06	0.12	0.14	
777.4	0.07	0.15	0.16	X
781.1	0.07	0.15	0.16	X
797	0.07	0.14	0.15	
899	<i>a</i>	<i>a</i>	<i>a</i>	X
1169.0		0.01	0.025	
1208.7		0.005	0.02	D
1305.6	0.015	0.03	0.04	CH ₄
3715.4	0.06	0.11	0.15	X
3737 br	0.04	0.08	0.10	X

^a Unresolved from parent Me₃SiH bands in survey scans.

irradiation B and grew in strongly with irradiation C (Figure 4d).

Me₂SiH₂ + ¹⁸O₃. With ¹⁸O₃, the DS band at 3717.1 cm⁻¹ in the O-H stretching region was red-shifted to 3705.2 cm⁻¹. The D band at 1209.6 cm⁻¹ in the Si-O stretching region was red-shifted to 1174.4 cm⁻¹, and the M band at 1207.4 cm⁻¹ was red-shifted to 1170.4 cm⁻¹. The ¹⁸O shifts of product bands are listed in Table V. With scrambled ^{16,18}O₃, only bands that were present in pure ¹⁶O₃ and ¹⁸O₃ experiments appeared.

Me₂SiD₂ + O₃. Samples of Me₂SiD₂ and ozone were codeposited, and photolysis product absorptions are listed in Table V. A very strong DS band at 886.2 cm⁻¹ shifted to 875.2 cm⁻¹ with ¹⁸O. In the O-D stretching region, a DS band at 2740.2 cm⁻¹ shifted to 2723.5 cm⁻¹ with ¹⁸O.

Me₂SiH₂ + O. Samples of dimethylsilane and discharged oxygen were codeposited for 8 h. New absorptions appeared that belong to species DS, and other product bands not present in Me₂SiH₂/O₃ experiments were also produced by vacuum-ultraviolet photolysis of Ar/Me₂SiH₂.¹³

Me₃SiH + ¹⁶O₃. The matrix and gas-phase¹⁵ infrared spectra of Me₃SiH were in good agreement. Exposure of Ar/Me₃SiH/¹⁶O₃ samples to radiation produced new bands which are listed in Table VI along with their intensities during photolyses A-C. Figure 5a shows the survey infrared spectrum recorded with deposition, and Figure 5b shows the spectrum recorded with irradiation C. Two differences from MeSiH₃/O₃ and Me₂SiH₂/O₃ photolysis experiments were immediately apparent. First, two bands identified X appeared in the O-H stretching region at 3715.4 and 3737 cm⁻¹ whereas only one band appeared in this region for MeSiH₃ and Me₂SiH₂. Second, the CH₄ band at 1305.6 cm⁻¹ was produced by irradiations A and B as well as C whereas CH₄ appeared only with irradiation C for MeSiH₃ and Me₂SiH₂. In the Si=O stretching region the D band appeared with irradiation B and increased with irradiation C.

Me₃SiH + ¹⁸O₃. A similar experiment was performed with Me₃SiH and ¹⁸O₃. In the O-H stretching region the X bands at 3715.4 and 3737 cm⁻¹ were shifted to 3703.8 and 3726 cm⁻¹, respectively. Also, the doublet at 777.5 and 781.0 cm⁻¹ showed a large ¹⁸O shift to 761.8 and 764.8 cm⁻¹. The D band at 1208.7 cm⁻¹ shifted to 1173.5 cm⁻¹. The ¹⁸O shifts of product bands are listed in Table VII.

Me₃SiD + O₃. Samples of Me₃SiD and ozone were photolyzed, and product absorptions are listed in Table VII. A very intense X doublet at 895.4 and 899.7 cm⁻¹ was red-shifted to 887.3 and 891.1 cm⁻¹ with ¹⁸O. Two bands in the O-D stretching region at 2738.3 and 2754.4 cm⁻¹ shifted to 2721.8 and 2737 cm⁻¹, respectively, with ¹⁸O. Additionally, the strong X band at 729.7 cm⁻¹ shifted to 591.6 cm⁻¹ (H/D = 1.23), and the band at 285.1 cm⁻¹ had very little deuterium shift appearing at 284.6 cm⁻¹ with Me₃SiD.

Me₃SiH + O. Samples of trimethylsilane were codeposited with discharged oxygen. As with MeSiH₃ and Me₂SiH₂, a number of bands appeared which were also produced by vacuum-ultraviolet

TABLE VII: Isotopic Absorptions (cm⁻¹) Appearing on Irradiation of Argon Matrix Containing Trimethylsilane and Ozone

(CH ₃) ₃ SiH		(CH ₃) ₃ SiD		ident
¹⁶ O ₃	¹⁸ O ₃	¹⁶ O ₃	¹⁸ O ₃	
285.1	281.2	284.6	282.6	X
303.8	296	8		
346.9	342.7			
360.2	356.5	272.7	270.3	X
		613.2	609.4	
684 br	683 br			
729.7	726.2	591.6	587.2	X
745	745			
777.5, 781.0	761.8, 764.8	775.9	761.8	X
797 br	796 br			
899 ^a	893 ^a	895.4, 899.7 vs	887.3, 891.1	X
	1025.5		1025.1	carbinol
1169.0				
1208.7	1173.5	1208.7	1173.5	D
1305.6	1305.6			CH ₄
3715.4	3703.8	2738.3	2721.8	X
3737	3726	2754	2737	X

^a Intense shoulder on intense precursor band.

TABLE VIII: Positions and Absorbances of Product Bands after Irradiations B and C of Argon Matrix Containing Me₄Si, ¹⁶O₃, and ¹⁸O₃^a

ν/cm^{-1}	¹⁶ O ₃		¹⁸ O ₃ ν/cm^{-1}
	B	C	
3637.1	0.01	0.03	3626.9
1165.9	0.03	0.095	1165.2
			1025.1
996.0	0.04	0.14	
753.5	0.095	0.29	753.3
334.6	0.03	0.08	328.7

^a All of the above absorptions are assigned to the carbinol, Me₃SiCH₂OH.

photolysis of Ar/Me₃SiH.¹³ Other bands appeared at 284.8, 334.5, 730.9, 777.7, 804.0, 947.1, 1101, 1193, 1208.4, 1305.6, 1388.7, 3030, and 3712.1 cm⁻¹.

Me₄Si + ¹⁶O₃. Exposure of Ar/Me₄Si/¹⁶O₃ matrices to irradiation B produced new bands which are listed in Table VIII. These bands increased in intensity with irradiation C. The absence of a band in the Si=O stretching region is noteworthy. Analogous results were obtained with ¹⁸O₃.

Discussion

Reaction products will be identified, and mechanisms for these reactions will be proposed. The new species produced here all require oxygen atoms from O₃ or discharged O₂. Since no additional bands were observed in any of the experiments with scrambled ^{16,18}O₃ that were not present in either ¹⁶O₃ or ¹⁸O₃ experiments, it appears that all of the photoproducts contain only one oxygen atom.

MeSiH₃ + O₃. The M band at 1207.6 cm⁻¹, in the Si=O stretching region, is identified as the Si=O stretch of methylsilanone, Me(H)Si=O. This is in keeping with its ¹⁸O shift of 37.0 cm⁻¹, which is similar to the 43-cm⁻¹ ¹⁸O shift of the SiO diatomic molecule.¹ This identification is consistent with the small shift of 5.3 cm⁻¹ when MeSiD₃ is employed. No other M bands were observed. This methylsilanone Si=O stretch at 1207.6 cm⁻¹ comes close to the Si=O stretch of unsubstituted silanone. H₂SiO, at 1202 cm⁻¹ in an argon matrix.¹ In fact, the weak B band at 1201.7 cm⁻¹, which appeared after irradiation C of matrices containing MeSiH₃ and ¹⁶O₃, is identified as H₂SiO.

The MS bands are assigned to methylsilanol, MeSiH₂OH, as is now discussed. The MS band at 3716.0 cm⁻¹ is clearly an O-H stretch since it has an ¹⁸O shift of 11.8 cm⁻¹. Furthermore, the two very strong MS bands at 2127.4 and 2138.0 cm⁻¹, which show no ¹⁸O shift, are appropriate for Si-H stretches since they come slightly to lower energy than the Si-H stretching absorptions of parent MeSiH₃. The very strong MS band at 718.5 cm⁻¹ which

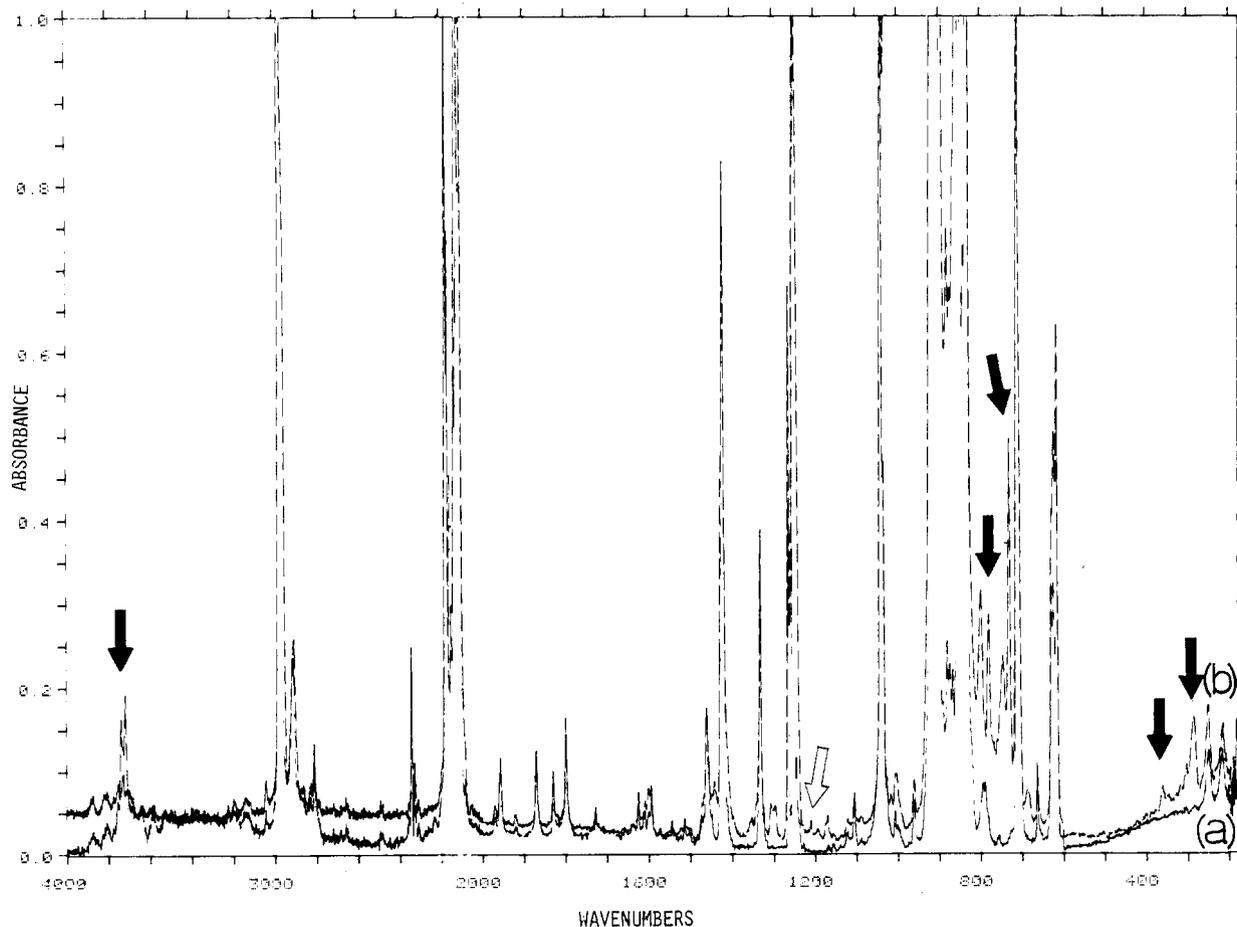


Figure 5. Infrared spectra of a sample of $\text{Ar}/\text{Me}_3\text{SiH}/^{16}\text{O}_3 = 400/1/1$ in the $180\text{--}4000\text{-cm}^{-1}$ region (a) immediately after deposition at $16\text{--}17\text{ K}$; (b) after irradiation C. Bold arrows indicate species X absorptions, and the light arrow shows a dimethylsilanone (D) band.

has a small ^{18}O shift of 0.7 cm^{-1} is assigned to an Si–O–H bend since it comes close to the Si–O–H bend of hydroxysilylene at 723 cm^{-1} .^{1,16} This is supported by its deuterium shift to 548 cm^{-1} ($\text{H}/\text{D} = 1.311$). The bands at 509.7 and 976.7 cm^{-1} also appear to belong to methylsilanol (MS) since their intensities bear a constant ratio to each other and to the intensity of the MS band at 718.5 cm^{-1} . The band at 976.7 cm^{-1} shows very little ^{18}O shift and a large MeSiD_3 shift to 753.7 cm^{-1} ($\text{H}/\text{D} = 1.296$). This band is most probably due to the H–Si–H bend since the H–Si–H bends of MeSiH_2X compounds ($\text{X} = \text{Me}, \text{F}, \text{Cl}, \text{Br}, \text{I}, \text{and CN}$) have been observed in the $980\text{--}940\text{-cm}^{-1}$ region.¹⁷ The MS band at 509.7 cm^{-1} which shows no measurable ^{18}O shift is probably due to the SiH_2 rock since such modes of the $\text{CH}_3\text{SiH}_2\text{X}$ compounds have been observed in the $520\text{--}460\text{-cm}^{-1}$ region.¹⁷ The band at 797.4 cm^{-1} , shifting to only 793.5 cm^{-1} with ^{18}O and 786.0 cm^{-1} with MeSiD_3 , is assigned to a CH_3 rock. The very intense band at 876.4 cm^{-1} with MeSiD_3 , which had a large shift of 17.0 cm^{-1} with ^{18}O , is assigned to the Si–O stretch of MeSiD_2OD . However, the ^{18}O shift of this band is still somewhat less than the ^{18}O shift of 27 cm^{-1} for the Si–O stretch of HSiOH .^{1,16} which occurs in the same frequency region. This is accounted for by mode mixing with SiD_2 and CH_3 deformation modes which come in the same frequency region. The Si–O stretch of fully protonated methylsilanol, MeSiH_2OH , was not observed, possibly because it is masked by the strong MeSiH_3 parent band centered by 870 cm^{-1} . There are two possible conformers of MeSiH_2OH since the hydroxyl substituent may be either trans or gauche to the methyl group as in ethanol,¹⁸ and it is likely that both conformers are trapped in the argon matrix.

$\text{Si}_2\text{H}_6 + \text{O}_3$. The disilane–ozone product bands are assigned to silylsilanol, $\text{SiH}_3\text{SiH}_2\text{OH}$. The band at 3708.5 cm^{-1} belongs to an O–H stretch since it has an ^{18}O shift of 11.5 cm^{-1} . The bands at 961.6 and 950.6 cm^{-1} are likely both due to H–Si–H bending modes of the $-\text{SiH}_2-$ and $-\text{SiH}_3$ groups since they appear in this characteristic frequency region. The band at 950.6 cm^{-1} is probably due to the H–Si–H bending mode of the $-\text{SiH}_2-$ group since it has an ^{18}O shift of 2.2 cm^{-1} and the $-\text{SiH}_2-$ group is linked to the O atom. The band at 961.6 cm^{-1} which shows no ^{18}O shift but a large deuterium shift to 704.4 cm^{-1} ($\text{H}/\text{D} = 1.365$) with Si_2D_6 is due to a $-\text{SiH}_3$ deformation. The other two SiH_3 deformations are probably masked by parent Si_2H_6 . The band at 855.0 cm^{-1} showing an ^{18}O shift of 2.9 cm^{-1} and a large deuterium shift to 637.4 cm^{-1} can be assigned to the $-\text{SiH}_2-$ twist. The band at 748 cm^{-1} shifting to 746 cm^{-1} with ^{18}O and to 556.9 cm^{-1} with deuterium is assigned to the Si–O–H bend coming in the same frequency region as the Si–O–H bend of HSiOH .^{1,16} Finally, the band at 521.7 cm^{-1} is assigned to the SiH_2 rock since it comes close to the SiH_2 rock of the analogous compound, MeSiH_2OH , which was observed at 509.7 cm^{-1} (see earlier).

$\text{Me}_2\text{SiH}_2 + \text{O}_3$. The D band at 1209.6 cm^{-1} which shifted 35.2 cm^{-1} with ^{18}O is assigned to the Si=O stretch of dimethylsilanone, $\text{Me}_2\text{Si}=\text{O}$, which is near the Si=O stretch of $\text{H}_2\text{Si}=\text{O}$ at 1202 cm^{-1} .¹ Furthermore, the band at 1209.6 cm^{-1} shows no deuterium shift when Me_2SiD_2 is employed. The Si=O stretching fundamental of Me_2SiO has been previously observed⁴ at 1204 cm^{-1} ; however, the discrepancy is almost certainly accounted for by the sensitivity of this fundamental to neighboring byproduct molecules. The M band at 1207.4 cm^{-1} is identified as the Si=O stretch of $\text{Me}(\text{H})\text{Si}=\text{O}$ as it shifts 37.0 cm^{-1} with ^{18}O .

Species DS has bands with isotopic shifts appropriate for identification as dimethylsilanol. The band at 3717.1 cm^{-1} shifting to 3705.2 cm^{-1} with ^{18}O is the O–H stretch, and this comes close to the O–H stretch of methylsilanol at 3716.0 cm^{-1} . The very intense band at 2111.0 cm^{-1} showing no ^{18}O shift belongs to the

(16) Ismail, Z. K.; Hauge, R. H.; Fredin, L.; Kaufman, J. W.; Margrave, J. L. *J. Chem. Phys.* **1982**, *77*, 1617.

(17) Ebsworth, E. A. V.; Onyszczuk, M.; Sheppard, N. *J. Chem. Soc.* **1958**, 1453.

(18) Barnes, A. J.; Hallam, H. E.; *Trans. Faraday Soc.* **1970**, *66*, 1932.

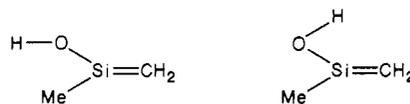
Si-H stretch. The doublet at 707.3 and 711.0 cm^{-1} shifting to 705.6 and 708.5 cm^{-1} with ^{18}O is assigned to the Si-O-H bend for two reasons. First, the small observed ^{18}O shift of 1.7 cm^{-1} (or 2.5 cm^{-1}) is approximately the same magnitude as the ^{18}O shift of 2.6 cm^{-1} observed for this mode of HSiOH.¹⁶ Second, this band appears in the same frequency region as the Si-O-H bend of HSiOH^{1,16} and methylsilanol, MeSiH₂OH (see earlier). When Me₂SiD₂ was employed, the counterpart of this band was not observed, but it is likely that it is shifted underneath the strong Me₂SiD₂ parent band which masked the 540–560- cm^{-1} region. The weak DS band at 283 cm^{-1} , exhibiting very little ^{18}O or D shift, is assigned to the C-Si-C skeletal bend. This fundamental is expected here since the C-Si-C bend of Me₂Si(OH)₂ in a KBr pellet has recently been observed at 250 cm^{-1} .¹³ The band at 616.2 cm^{-1} which has no ^{18}O shift also belongs to DS. It shifts down to 514.2 cm^{-1} with Me₂SiD₂ bearing a ratio of 1.20 with its protonated counterpart. It is possibly due to a mixture of a methyl rock and a H-Si-C bend since, in both Me₂SiH₂/O₃ and Me₂SiD₂/O₃ experiments, this DS band is a lower energy satellite of the dimethylsilane ν_{21} fundamental¹⁵ which is a mixture of a methyl rock and SiH₂ wag. Likewise the very strong DS band at 925 cm^{-1} which has no ^{18}O shift occurs as a higher energy satellite of the ν_{19} fundamental of Me₂SiH₂ which is also a mixture of a methyl rock and SiH₂ wag.¹⁵ With Me₂SiD₂, the DS band at 925 cm^{-1} shifts down to 811 cm^{-1} (H/D = 1.14) occurring as a higher energy satellite of the ν_{19} parent Me₂SiD₂. Therefore, it is likely that the DS band at 925 cm^{-1} is also due to a mixture of methyl rock and H-Si-C bend. The doublet of bands at 757.2 and 764.5 cm^{-1} shifting to 755.5 and 763.4 cm^{-1} with ^{18}O also belong to DS. It appears that this doublet is red-shifted to 612.1 cm^{-1} (H/D = 1.24) in Me₂SiD₂ + $^{16}\text{O}_3$ experiments (2.5 cm^{-1} ^{18}O shift). This suggests it as a possible candidate for the H-Si-O bend. The band at 819.4 cm^{-1} exhibiting a considerable shift of 9.1 cm^{-1} with ^{18}O is possibly due to the CH₃ symmetric rock; however, no firm assignment can be made since its deuterium counterpart was not observed. The very strong band at 886.2 cm^{-1} with Me₂SiD₂, which had an ^{18}O shift of 11.0 cm^{-1} , is assigned to the Si-O stretch of Me₂SiDOD since it has the largest ^{18}O shift of all the bands observed in this frequency region and it comes close to the band at 876.4 cm^{-1} which was assigned to the Si-O stretch of MeSiD₂OD (see earlier). The Si-O stretch of fully protonated dimethylsilanol, Me₂SiHOH, was not observed, possibly because it is masked by the strong Me₂SiH₂ parent peak absorbing in the 860–870- cm^{-1} region. As with MeSiH₂OH there are two possible conformers of Me₂SiHOH since the OH group may be either trans or gauche to the silyl hydrogen. This is possibly the reason why the Si-O-H bend appears as a doublet at 707.3 and 711.0 cm^{-1} , the individual components of which do not have exactly the same ^{18}O shift.

Me₃SiH + O₃. The D band at 1208.7 cm^{-1} is assigned to the Si=O stretch of dimethylsilanone, Me₂SiO, in close proximity to a CH₄ byproduct molecule. This identification is made on the basis of the ^{18}O isotopic shift of 35.2 cm^{-1} which is identical with the ^{18}O shift observed for the Si=O stretch of Me₂SiO product in Me₂SiH₂/O₃ experiments. Further support for the identification of the 1208.7- cm^{-1} band as the Si=O stretch of Me₂SiO was the lack of an isotopic shift when Me₃SiD was employed. The band at 1305.6 cm^{-1} which grows in with the 1208.7- cm^{-1} absorption is due to the CH₄ byproduct. It is notable that the Si=O stretch of Me₂SiO from Me₃SiH and O₃ precursors comes 0.9 cm^{-1} lower than the Si=O stretch of Me₂SiO from Me₂SiH₂ and O₃ precursors. This discrepancy is probably due to the perturbing influence of the neighboring CH₄ molecule which was not present in dimethylsilane experiments.

The other product bands (see Table VI) are clearly not due to trimethylsilanol, Me₃SiOH.¹⁹ This was an expected product since methylsilanol, MeSi₂OH, and dimethylsilanol, Me₂SiHOH, were formed in high yield in parallel MeSiH₃/O₃ and Me₂SiH₂/O₃ photolysis experiments. In order to determine matrix shifts for

Me₃SiOH bands compared to the gas phase, a sample of Me₃SiOH was prepared²⁰ and its matrix infrared spectrum recorded. There was good agreement between matrix and gas-phase infrared spectra of Me₃SiOH.¹⁹ Therefore, it can be concluded that Me₃SiOH was not a product of the matrix photolysis of Me₃SiH and O₃. Finally, the 1305.6- cm^{-1} methane band grows in gradually throughout the irradiation sequence A-C. Therefore, CH₄ is produced in the photolysis of Me₃SiH/O₃, which also rules out the formation of Me₃SiOH from Me₃SiH and O₃.

The identification of species X can now be considered. The broad band at 3737 cm^{-1} shifting to 3726 cm^{-1} and the band at 3715.4 cm^{-1} shifting to 3703.8 cm^{-1} with ^{18}O are both appropriate for O-H stretches. The very strong band at 729.7 cm^{-1} which shifts to 726.2 cm^{-1} with ^{18}O is assigned to an Si-O-H bend. This assignment is supported by the deuterium shift to 591.6 cm^{-1} (H/D = 1.23) with Me₃SiD, which indicates a large percentage of hydrogen character in this mode. The band at 360.2 cm^{-1} , which shifts down to 356.5 cm^{-1} with ^{18}O and shows a large shift to 284.6 cm^{-1} (H/D = 1.32) with Me₃SiD is almost certainly due to a H-O-Si-C torsion, since this mode involves the H atom which undergoes isotopic substitution. The doublet at 777.5 and 781.0 cm^{-1} , showing an ^{18}O shift of 16.0 cm^{-1} , the largest observed in this spectrum, is assigned to an Si-O stretch. This assignment is made on account of the high percentage oxygen character of this mode even though a pure Si-O bond stretch should show an ^{18}O shift of approximately 28 cm^{-1} in this frequency region. It is striking that this Si-O stretching frequency is considerably lower than the Si-O stretches observed for MeSiD₂OD and Me₂SiDOD (see above) and the Si-O stretch of gas-phase Me₃SiOH, which was reported at 915 cm^{-1} .¹⁹ The very strong band at 899 cm^{-1} , which is shifted to 893 cm^{-1} with ^{18}O and shows very little deuterium shift, is most probably due to a mode involving Si=C stretching and methyl rocking character since these modes, which occur in this frequency region, are often very intense. The band at 285.1 cm^{-1} shifting to 281.2 cm^{-1} with ^{18}O and showing very little deuterium shift may be due to a C-Si-C bend as it comes in this particular frequency region. It appears quite possible that species X is the enol isomer of dimethylsilanone, namely, the substituted silaethylene, Me(HO)Si=CH₂, which has the reagent stoichiometry plus O minus CH₄. The infrared data are consistent with such a structure. Perhaps the two hydroxyl stretches which are observed at 3715.4 and 3737 cm^{-1} are due to the two distinct isomeric structures



No Me₃SiOH was detected from the reaction of O atoms with Me₃SiH either. However, a band appeared at 1208.4 cm^{-1} which is due to the Si=O stretch of Me₂SiO as it comes very close to the Me₃SiH/O₃ photolysis product. Furthermore, the yield of Me₂SiO in the discharge experiment was approximately 5 times that of the ozone photolysis experiments. Other weak features which have not been identified appeared at 730.0, 736.5, 777.7, 804.0, 947.1, 1100.7, and 1193 cm^{-1} (broad) in the discharge experiment.

Me₄Si + O₃. It seems likely that there is O atom insertion into a C-H bond of this fully methyl substituted silane to give a carbinol. The band at 1025.1 cm^{-1} in the Me₄Si/ $^{18}\text{O}_3$ experiment is likely due to the C- ^{18}O stretch with the C- ^{16}O stretch in the Me₄Si/ $^{16}\text{O}_3$ experiment almost certainly masked by the strong $^{16}\text{O}_3$ band at 1040 cm^{-1} .⁷ This C-O stretching frequency comes very close to the C-O stretch of CH₃OH in solid argon at 1034.0 cm^{-1} which shifted to 1008.2 cm^{-1} with ^{18}O .²¹ In the hydroxyl region the band at 3637.1 cm^{-1} (10.2- cm^{-1} with ^{18}O) is clearly the O-H stretch of this carbinol. It is distinct from the O-H

(19) Rouviere, J.; Tabacik, V.; Fleury, G. *Spectrochim. Acta, Part A* **1973**, *29A*, 229.

(20) See Sauer, R. O. *J. Am. Chem. Soc.* **1944**, *66*, 1707 for the preparation details of Me₃SiOH. The ^1H NMR spectrum contained two peaks having relative intensities of 9.6:1, which is close to the expected ratio of 9:1.

(21) Barnes, A. J.; Hallam, H. E. *Trans. Faraday Soc.* **1970**, *66*, 1920.

product stretches in MeSiH₃, Me₂SiH₂, and Me₃SiH experiments since these silanol O–H stretches have higher frequencies in the 3700-cm⁻¹ region. The band in the low-frequency region at 334.6 cm⁻¹ (¹⁸O shift of 5.9 cm⁻¹) most probably belongs to the Si–C–O bend of the carbinol. The strong band at 753.5 cm⁻¹ (¹⁸O shift of 0.2 cm⁻¹) is possibly due to the –CH₂– rock of the –SiCH₂OH group. In addition, the band at 1165.9 cm⁻¹ (¹⁸O shift of 0.7 cm⁻¹) may well be due to the H–C–H bend of the methylene group. Assignment of the product band at 996.0 cm⁻¹ is not attempted as its ¹⁸O shift was not determined, probably owing to masking by ν₃ of ¹⁸O₃.

Mechanisms. Formation of the alcohol products discussed in the foregoing section can be envisioned by oxygen atom insertion into either a Si–H or, in the case of Me₄Si, a C–H bond. The insertion of O atoms into Si–H bonds has been reported in similar studies with SiH₄¹ and SiHCl₃.² Likewise, oxygen atoms insert into C–H bonds of CH₄ to give CH₃OH²² and C₂H₄ to give vinyl alcohol.²³ In the present study with methyl-substituted silanes, the O atom has a choice of insertion into a Si–H bond or a C–H bond (except for Me₄Si). These experiments indicate that O atom insertion into a Si–H bond is clearly favored. For example, with MeSiH₃, which has three Si–H bonds and three C–H bonds, methylsilanol was formed in high yield and no carbinol was detected. However, in photolysis experiments with Me₃SiH, which has one Si–H bond and nine C–H bonds, a trace of the carbinol was produced in addition to the major product which has been tentatively identified as H₂C=Si(OH)Me. These observations are consistent with a thermodynamic preference for O atom insertion into a Si–H (*D*[Si–H] ~ 90 kcal mol⁻¹) rather than a C–H bond (*D*[C–H] ~ 100 kcal mol⁻¹). In spite of this thermodynamic preference to form the silanol rather than the carbinol, a small amount of carbinol was formed in Me₃SiH/O₃ photolysis experiments because it is kinetically favored.

(i) **Substituted Methylsilane + O Atom Discharge Experiments.** MeSiH₃/O atom experiments contrasted rather strikingly with SiH₄/O atom discharge experiments.¹ The latter gave little evidence for silanol, H₃SiOH, but hydroxysilylene, HSiOH, was produced in high yield.¹ On the other hand, methylsilanol, MeSiH₂OH, was formed in high yield, and there was no evidence for the silylenes HSiOH or MeSiOH in MeSiH₃/O atom discharge experiments. It seems likely that O atom insertion into a Si–H bond of SiH₄ produces an energized silanol molecule which eliminates molecular hydrogen to give HSiOH.



However, the energized methylsilanol molecule, produced by O atom insertion into a Si–H bond of MeSiH₃, does not dissociate as rapidly, and the excess energy relaxes by intramolecular vibrational energy transfer and is quenched by the matrix.



It is presumed that [H₃SiOH]^{*} dissociates more readily than [MeSiH₂OH]^{*} because the excess energy is distributed over fewer vibrational modes. Me₂SiHOH is similarly produced in Me₂SiH₂ + O atom experiments.

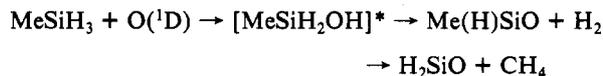
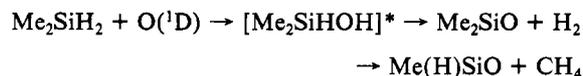


In Me₃SiH + O atom discharge experiments the Me₂SiO product is almost certainly produced via an energized Me₃SiOH intermediate.

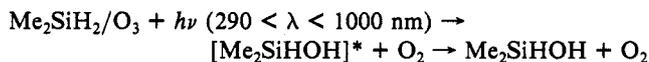
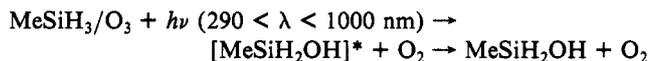


(ii) **Substituted Methylsilane + Ozone Photolysis Experiments.** The mechanism of formation of the methylsilanones, which occurs under full-arc (220 < λ < 1000 nm) conditions, most probably involves H₂ or CH₄ molecular elimination from the vibrationally excited methylsilanols. Both H₂ and CH₄ elimination may occur

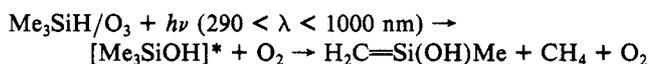
as the Si–H and Si–C bond energies are nearly equivalent.²⁴ However, the relative yields of the dimethyl-substituted methyl-substituted, and unsubstituted silanones demonstrate that Si–H cleavage is favored.



When the incident radiation is less energetic (290 < λ < 1000 nm), MeSiH₂OH and Me₂SiHOH are not born with sufficient excess energy to undergo unimolecular dissociation.



Failure to observe trimethylsilanol, Me₃SiOH, in Me₃SiH/O₃ photolysis strikingly contrasts the formation of MeSiH₂OH and Me₂SiHOH in the respective MeSiH₃ and Me₂SiH₂ experiments. Me₃SiH/O₃ photolysis probably proceeds via [Me₃SiOH]^{*}, however, to give H₂C=S(OH)Me, an isomer of Me₂SiO.



It appears likely that [Me₃SiOH]^{*} may eliminate methyl radical more readily than excited methyl- or dimethylsilanols owing to increased stability of the more highly substituted silyl free radical. Once produced, CH₃ can then abstract the hydroxyl hydrogen or a methyl hydrogen to give the silanone or its enol form. Me₂SiO is probably more thermodynamically stable than its enol isomer, H₂C=Si(OH)Me, since the similar Me(H)SiO molecule has been calculated to be 21.2 kcal mol⁻¹ lower in energy than its enol isomer, H₂C=SiHOH, at the MP3/6-31G* level.²⁵ The formation and trapping of H₂C=Si(OH)Me in spite of its higher energy with respect to Me₂SiO is reasonable, though, as long as the barrier to isomerization via intramolecular rearrangement is high. Such is the case with vinyl alcohol, which is less thermodynamically stable than the acetaldehyde isomer, but nevertheless vinyl alcohol has been produced by photolysis in solid argon matrices.²³

The Si₂H₆/O₃ photolysis experiments *exclusively* gave insertion into a Si–H bond and the silylsilanol product; disiloxane was not detected. This may be surprising owing to the long, weak Si–Si bond.

Conclusions

Methyl- and dimethylsilanols have been observed from O atom reactions and O₃ photolysis (290 < λ < 1000 nm) in argon matrices containing MeSiH₃ and Me₂SiH₂, respectively. Similarly, in Si₂H₆/O₃ photolysis experiments, product bands were observed which are identified as silylsilanol, SiH₃SiH₂OH. The O–H stretching frequency of these silanols appears in the 3700-cm⁻¹ region close to the O–H stretches of Cl₃SiOH (3639.5 cm⁻¹ in solid argon)² and Me₃SiOH (3737 cm⁻¹ in gas phase).¹⁹

Me₃SiOH was not identified in the reactions of oxygen atoms with Me₃SiH; however, in Me₃SiH/O atom discharge experiments, Me₂SiO was produced. When argon matrices containing Me₃SiH/O₃ were irradiated in the region 290 < λ < 1000 nm, a new set of bands appeared that have tentatively been assigned to H₂C=Si(OH)Me, the enol isomer of Me₂SiO.

Full mercury arc irradiation (220 < λ < 1000 nm) of argon matrices containing Me₃SiH/O₃ gave dimethylsilanone, Me₂SiO.

(22) Withnall, R.; Andrews, L., unpublished results, 1986.

(23) Hawkins, M.; Andrews, L. *J. Am. Chem. Soc.* **1983**, *105*, 2523.

(24) Walsh, R. *Acc. Chem. Res.* **1981**, *14*, 246.

(25) Gordon, M. S.; George, C. *J. Am. Chem. Soc.* **1984**, *106*, 609.

Similarly, Me₂SiO and Me(H)SiO were observed in Me₂SiH₂/O₃ experiments, and Me(H)SiO and H₂SiO were produced in Me-SiH₃/O₃ experiments. Both H₂ and CH₄ eliminate from excited methylsilanols cleaving Si-H or Si-C bonds; however, the relative yields of the silanone products show that Si-H cleavage is favored. No silanones were observed in similar Me₄Si/O₃ experiments, but new bands appeared that likely belong to the carbinol resulting from O atom insertion into a C-H bond of Me₄Si.

The argon matrix is a convenient vehicle for first-step oxidation of reactive compounds like the silanes with infrared spectroscopic identification of the products.

Acknowledgment. We gratefully acknowledge financial support from NSF Grant 85-16611 and helpful discussion with C. A. Arrington.

Registry No. O₃, 10028-15-6; MeSiH₃, 992-94-9; Me(H)Si=O, 43435-60-5; ¹⁸O₃, 21424-26-0; H₂SiO, 22755-01-7; MeSiH₂OH, 111935-69-4; MeSiD₃, 1066-43-9; MeSiD₂OD, 111935-70-7; SiH₃SiH₂OH, 87963-93-7; Si₂H₆, 1590-87-0; Me₂SiH₂, 1111-74-6; Me₂Si=O, 47956-45-6; Me₂SiD₂, 1066-41-7; Me₂SiHOH, 5906-76-3; Me₂SiDOD, 111935-71-8; Me₃SiH, 993-07-7; Me₃SiD, 18026-91-0; Me(HO)Si=CH₂, 111935-72-9; Me₄Si, 75-76-3; Me₃SiCH₂OH, 3219-63-4; Si₂D₆, 13537-08-1; O, 17778-80-2.

A Quasi-Classical Approximation for Autocorrelation Functions

Seon-Woog Cho

Department of Chemistry, Kansas State University, Manhattan, Kansas 66506

and Kenneth G. Kay*

Department of Chemistry, Kansas State University, Manhattan, Kansas 66506, and Department of Chemistry, Bar-Ilan University, Ramat-Gan 52100, Israel (Received: May 26, 1987; In Final Form: August 24, 1987)

A quasi-classical approximation is presented for the calculation of time autocorrelation functions of properties of bound molecular systems. In this treatment, classical motion is restricted to quantized invariant tori on a discretized energy shell. The dynamics on these tori is obtained by the adiabatic switching technique. When applied to the Henon-Heiles system, the quasi-classical approximation is sometimes found to yield significantly better agreement with the quantum results than that obtained from conventional classical calculations.

I. Introduction

Time correlation functions are of central importance for the description of motion in isolated, molecular systems. Somewhat different versions of such functions are used to determine optical spectra,¹⁻³ to calculate probabilities for transitions among internal states,⁴⁻⁶ to formulate stochastic theories of intramolecular dynamics,⁷ and to detect the presence of chaotic⁸ or ergodic behavior.⁹⁻¹³

Since a full quantum mechanical calculation of such functions is usually not feasible, it is desirable to develop various classical approximations. The goal of this paper is to present one such approximation that is sometimes capable of yielding good agreement with the exact quantum results.

The original motivation for this work came from an earlier comparison¹⁰ between quantum and analogous classical autocorrelation functions for the Henon-Heiles¹⁴ system. Although the quantum and classical quantities were generally found to agree well when the energy of the system was high, they were sometimes found to disagree significantly when the energy of the system was lower. The explanation offered for these discrepancies implied that the agreement could be improved if the classical calculations were confined to a set of discrete invariant tori corresponding to states contributing to the quantum dynamics. This idea forms the basis for the present work.

We organize the remainder of this paper as follows. In section II, we describe our basic method for simulating quantum correlation functions. In section III, we present more details about the application of this technique to the Henon-Heiles system. In section IV we compare autocorrelation functions computed by the present method to exact quantum and conventional classical autocorrelation functions. Finally, in section V, we make some concluding remarks.

II. Approach

The time-autocorrelation functions we explore here are of the form

$$C_A(t) = \text{Tr}[\rho^\sigma(E - \hat{H})\hat{A}(t)^\dagger \hat{A}] / \text{Tr}[\rho^\sigma(E - \hat{H})\hat{A}^\dagger \hat{A}] \quad (1)$$

where \hat{A} is a quantum operator, $\hat{A}(t)$ is this operator at time t in the Heisenberg representation, and \hat{H} is the Hamiltonian for the system. The quantity ρ^δ is a "broadened delta function" which projects onto states in the energy shell of half-width δ about energy E . Specifically, we use the expression

$$\rho^\sigma(E - \hat{H}) = \exp[-(E - \hat{H})^2 / 2\sigma^2] \quad (2)$$

although others may be applied.

The form of $C_A(t)$ defined above is general enough to be useful in many physical cases. For example, if σ is chosen to be very

(1) Breene, R. G. *Theories of Spectral Line Shape*; Wiley-Interscience: New York, 1981.

(2) Koszykowski, M. L.; Noid, D. W.; Marcus, R. A. *J. Phys. Chem.* **1982**, *86*, 2113.

(3) Wardlaw, D. M.; Noid, D. W.; Marcus, R. A. *J. Phys. Chem.* **1984**, *88*, 536.

(4) Kay, K. G. *J. Chem. Phys.* **1980**, *72*, 5955.

(5) Hutchinson, J. S.; Wyatt, R. E. *Phys. Rev. A* **1981**, *23*, 1567.

(6) Davis, M. J.; Heller, E. J. *J. Chem. Phys.* **1984**, *80*, 5036.

(7) Mukamel, S. *J. Chem. Phys.* **1979**, *71*, 2012.

(8) Noid, D. W.; Koszykowski, M. L.; Marcus, R. A. *J. Chem. Phys.* **1977**, *67*, 404.

(9) Kay, K. G. *J. Chem. Phys.* **1983**, *79*, 3026.

(10) Ramachandran, G.; Kay, K. G. *J. Chem. Phys.* **1985**, *83*, 6316.

(11) Ramachandran, B.; Kay, K. G. *J. Chem. Phys.* **1987**, *86*, 4628.

(12) Koszykowski, M. L.; Noid, D. W.; Tabor, M.; Marcus, R. A. *J. Chem. Phys.* **1981**, *74*, 2530.

(13) Hamilton, I.; Carter, D.; Brumer, P. *J. Phys. Chem.* **1982**, *86*, 2124. Hamilton, I.; Brumer, P. *J. Chem. Phys.* **1983**, *78*, 2682.

(14) Henon, M.; Heiles, C. *Astron. J.* **1964**, *69*, 73.

* Address reprint requests to Bar-Ilan University.